



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hong-Jyh Li et al.

Examiner: Quoc Dinh Hoang

Serial No.: 10/799,910

Group Art Unit: 2818

Filed: March 12, 2004

Docket No.: I331.135.101/2004P50029US

Title: ION IMPLANTATION OF HIGH-K MATERIALS IN SEMICONDUCTOR DEVICES

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

We are transmitting herewith the attached:

- ☒ Transmittal Sheet containing Certificate of Mailing under 37 C.F.R. 1.8
- ☒ Amendment and Response 7 pgs.
- ☐ Petition for a Extension of Time 1 pg.
- ☐ The Commissioner is authorized to charge \$0.00 to Deposit Account No. 500471 to cover any additional claims fees
- ☐ The Commissioner is authorized to charge to Deposit Account No. 500471 to cover the Extension of Time fees
- ☐ Other: _____
- ☐ Other Fees: The Commissioner is authorized to charge \$0.00 to Deposit Account No. 500471 to cover _____
- ☒ Return Postcard

Claims as Amended:						
	Claims Remaining After Amendment	Highest Number Previously Paid For	Extra	Rate		Fee
TOTAL CLAIMS	15	40	0	X	\$50.00	\$0.00
INDEPENDENT CLAIMS	2	6	0	X	\$200.00	\$0.00
MULTIPLE CLAIMS PRESENTED	No					\$0.00
				TOTAL		\$0.00

Customer No. 025281

By

Name: Mark A. Peterson (Reg. No. 50,485)

Please consider this a Petition for Extension of Time for a sufficient number of months to enter these papers, if appropriate. At any time during the pendency of this application, please change any additional fees or credit overpayment to Deposit Account No. 500471.

CERTIFICATE UNDER 37 C.F.R. 1.8:

Date of Deposit: February 28, 2006

The undersigned hereby certifies that this paper or papers, as described herein, are being deposited in the United States Postal Service, as First Class mail, addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Name: Mark A. Peterson



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AMENDMENT AND RESPONSE

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This Amendment and Response is in reply to the Office Action mailed November 29, 2005. Please amend the above-identified patent application as follows: